

Jen-Inn Chyi

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/1509108/publications.pdf>

Version: 2024-02-01

336
papers

6,247
citations

71102

41
h-index

102487

66
g-index

336
all docs

336
docs citations

336
times ranked

4999
citing authors

#	ARTICLE	IF	CITATIONS
1	Performance Comparison of Lattice-Matched AlInN/GaN/AlGaIn/GaN Double-Channel Metal-Oxide-Semiconductor High-Electron Mobility Transistors with Planar Channel and Multiple-Mesa-Fin-Channel Array. <i>Materials</i> , 2022, 15, 42.	2.9	1
2	AlInGaIn/GaN HEMTs With High Johnson's Figure-of-Merit on Low Resistivity Silicon Substrate. <i>IEEE Journal of the Electron Devices Society</i> , 2021, 9, 130-136.	2.1	7
3	Lattice-Matched AlInN/GaN/AlGaIn/GaN Heterostructured-Double-Channel Metal-Oxide-Semiconductor High-Electron Mobility Transistors with Multiple-Mesa-Fin-Channel Array. <i>Materials</i> , 2021, 14, 5474.	2.9	3
4	Design and Simulation of High Performance Lattice Matched Double Barrier Normally Off AlInGaIn/GaN HEMTs. <i>IEEE Journal of the Electron Devices Society</i> , 2020, 8, 873-878.	2.1	10
5	Crystal Transformation of Cubic BN Nanoislands to Rhombohedral BN Sheets on AlN for Deep-UV Light-Emitting Diodes. <i>ACS Applied Nano Materials</i> , 2020, 3, 5285-5290.	5.0	2
6	The Influence of Superlattice Structure on the Dynamic Buffer Response of AlInN/GaN-on-Si HEMTs. <i>IEEE Nanotechnology Magazine</i> , 2020, 19, 415-420.	2.0	4
7	High Electron Mobility of 1880 cm ² V ⁻¹ S ⁻¹ In _{0.17} Al _{0.83} N/GaN-on-Si HEMTs with GaN Cap Layer. , 2020, , .		0
8	Enhanced Electrical Properties of AlInN/AlN/GaN Heterostructure using $\text{Al}_{1-x}\text{Ga}_x\text{N}/\text{Al}_y\text{Ga}_{1-y}\text{N}$ superlattice. , 2019, , .		0
9	Improved optical properties of InAs submonolayer quantum dots in GaAsSb/InGaAs double-well structure. <i>Applied Physics Letters</i> , 2019, 115, .	3.3	3
10	Fabrication of $0.25 \mu\text{m}$ T-Gate AlInGaIn/AlN/GaN HEMTs by I-Line Optical Lithography. , 2019, , .		0
11	Achieving high electron mobility in AlInGaIn/GaN heterostructures: The correlation between thermodynamic stability and electron transport properties. <i>Applied Physics Letters</i> , 2019, 114, 222103.	3.3	5
12	Design and Demonstration of Tunable Amplified Sensitivity of AlGaIn/GaN High Electron Mobility Transistor (HEMT)-Based Biosensors in Human Serum. <i>Analytical Chemistry</i> , 2019, 91, 5953-5960.	6.5	34
13	Dynamic monitoring of transmembrane potential changes: a study of ion channels using an electrical double layer-gated FET biosensor. <i>Lab on A Chip</i> , 2018, 18, 1047-1056.	6.0	16
14	A Comprehensive Model for Whole Cell Sensing and Transmembrane Potential Measurement Using FET Biosensors. <i>ECS Journal of Solid State Science and Technology</i> , 2018, 7, Q3001-Q3008.	1.8	12
15	High sensitivity cardiac troponin I detection in physiological environment using AlGaIn/GaN High Electron Mobility Transistor (HEMT) Biosensors. <i>Biosensors and Bioelectronics</i> , 2018, 100, 282-289.	10.1	128
16	Enumeration of circulating tumor cells and investigation of cellular responses using aptamer-immobilized AlGaIn/GaN high electron mobility transistor sensor array. <i>Sensors and Actuators B: Chemical</i> , 2018, 257, 96-104.	7.8	29
17	Beyond the Limit of Ideal Nernst Sensitivity: Ultra-High Sensitivity of Heavy Metal Ion Detection with Ion-Selective High Electron Mobility Transistors. <i>ECS Journal of Solid State Science and Technology</i> , 2018, 7, Q176-Q183.	1.8	11
18	High Performance InAlN/GaN/Si High Electron Mobility Transistor Using Microwave Ohmic Annealing Technique. <i>ECS Journal of Solid State Science and Technology</i> , 2018, 7, Q185-Q189.	1.8	1

#	ARTICLE	IF	CITATIONS
19	Direct detection of DNA using electrical double layer gated high electron mobility transistor in high ionic strength solution with high sensitivity and specificity. <i>Sensors and Actuators B: Chemical</i> , 2018, 271, 110-117.	7.8	19
20	High-field modulated ion-selective field-effect-transistor (FET) sensors with sensitivity higher than the ideal Nernst sensitivity. <i>Scientific Reports</i> , 2018, 8, 8300.	3.3	26
21	Effects of GaSb surface preparation on the characteristics of HfO ₂ /Al ₂ O ₃ /GaSb metal-oxide-semiconductor capacitors prepared by atomic layer deposition. <i>Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films</i> , 2017, 35, .	2.1	5
22	Suppressing Ge diffusion by GaAsSb barriers in molecular beam epitaxy of InGaAs on Ge. <i>Physica Status Solidi (B): Basic Research</i> , 2017, 254, 1600589.	1.5	0
23	Direct detection of fibrinogen in human plasma using electric-double-layer gated AlGaIn/GaN high electron mobility transistors. <i>Applied Physics Letters</i> , 2017, 111, .	3.3	11
24	Improved reverse recovery characteristics of InAlN/GaN schottky barrier diode using a SOI substrate. <i>Semiconductor Science and Technology</i> , 2017, 32, 105009.	2.0	2
25	Beyond the Debye length in high ionic strength solution: direct protein detection with field-effect transistors (FETs) in human serum. <i>Scientific Reports</i> , 2017, 7, 5256.	3.3	173
26	Enhancing the Performance of AlGaIn/GaN Schottky Barrier Diodes by SF ₆ Plasma Treatment and Deep Anode Recess. <i>ECS Journal of Solid State Science and Technology</i> , 2017, 6, S3081-S3083.	1.8	3
27	InAlN/GaN HEMT using microwave annealing for low temperature ohmic contact formation. , 2017, , .		0
28	Pt/GaN Schottky Diodes for Highly Sensitive Hydrogen Sulfide Detection. <i>ECS Journal of Solid State Science and Technology</i> , 2016, 5, Q137-Q139.	1.8	4
29	Influence of Point Defects on the Properties of Undoped and Ga-Doped ZnO Films Grown by Plasma-Assisted Molecular Beam Epitaxy in an O-Rich Environment. <i>ECS Journal of Solid State Science and Technology</i> , 2016, 5, Q222-Q225.	1.8	10
30	Suppressing Ge diffusion by GaAsSb for molecular beam epitaxy of InGaAs on Ge. , 2016, , .		0
31	Bandgap engineering for normally-off GaAsSb/InGaAs hetero-junction tunneling field-effect transistors with high on-state current. , 2016, , .		0
32	High Thermal Stability of GaN Schottky Diode with Diamond-Like Carbon (DLC) Anode Design. <i>Journal of the Electrochemical Society</i> , 2016, 163, H155-H158.	2.9	3
33	The Characterization of InAlN/AlN/GaN HEMTs Using Silicon-on-Insulator (SOI) Substrate Technology. <i>Journal of the Electrochemical Society</i> , 2016, 163, H110-H114.	2.9	4
34	Bottom-up Nano-scale heteroepitaxy of Wafer-scale Semipolar GaN on (001) Si. <i>Advanced Materials</i> , 2015, 27, 4845-4850.	21.0	9
35	Reduced Interface States of Atomic-Layer-Deposited Al ₂ O ₃ /AlGaIn/GaN Heterostructure Containing In Situ Grown AlN/GaN Cap Layer and Subjected to Thermal Oxidation. <i>Journal of the Electrochemical Society</i> , 2015, 162, E160-E165.	2.9	1
36	Analysis of Threshold Voltage Shift in AlGaIn/GaN Heterostructure Field-Effect Transistors with Different Buffer Layers. <i>Journal of the Electrochemical Society</i> , 2015, 162, H522-H526.	2.9	2

#	ARTICLE	IF	CITATIONS
37	Low resistivity and low compensation ratio Ga-doped ZnO films grown by plasma-assisted molecular beam epitaxy. <i>Journal of Crystal Growth</i> , 2015, 425, 216-220.	1.5	8
38	A Study on the Fiber Dispersion Effect for the Generation of Quasi-Sinusoidal Terahertz Modulations on Optical Pulses. <i>Journal of Lightwave Technology</i> , 2015, 33, 4899-4907.	4.6	2
39	Investigations of dynamic performance in AlGaIn/GaN HFETs with field plates by stressed V_{GS} and dynamic on-resistance measurements. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2015, 212, 1099-1103.	1.8	0
40	Analysis of the Back-Gate Effect in Normally OFF p-GaN Gate High-Electron Mobility Transistor. <i>IEEE Transactions on Electron Devices</i> , 2015, 62, 507-511.	3.0	23
41	Improving the off-state characteristics and dynamic on-resistance of AlInN/AlN/GaN HEMTs with a GaN cap layer. <i>Applied Physics Express</i> , 2015, 8, 064102.	2.4	10
42	Device stress evaluation of InAs/AlSb HEMT on silicon substrate with refractory iridium Schottky gate metal. <i>Microelectronic Engineering</i> , 2015, 138, 17-20.	2.4	4
43	High hole mobility InGaSb/AlSb QW field effect transistors grown on Si by molecular beam epitaxy. <i>Journal of Crystal Growth</i> , 2015, 425, 385-388.	1.5	4
44	The device characteristics of Ir- and Ti-based Schottky gates AlSb/InAs high electron mobility transistors. <i>Microelectronics Reliability</i> , 2015, 55, 890-893.	1.7	1
45	Trap-Profile Extraction Using High-Voltage Capacitance-Voltage Measurement in AlGaIn/GaN Heterostructure Field-Effect Transistors With Field Plates. <i>IEEE Transactions on Electron Devices</i> , 2015, 62, 835-839.	3.0	12
46	Yellow-emitting Si-doped GaN: Favorable characteristics for intermediate band solar cells. <i>Solar Energy Materials and Solar Cells</i> , 2015, 132, 544-548.	6.2	12
47	A Self-Assembled Double-Island Buffer Structure for Improving GaN-Based Materials Grown on Si Substrates. <i>ECS Journal of Solid State Science and Technology</i> , 2014, 3, R229-R233.	1.8	0
48	Quantum control study of ultrafast optical responses in semiconductor quantum dot devices. <i>Optics Express</i> , 2014, 22, 30815.	3.4	1
49	Passivation of GaSb using molecular beam epitaxy Y ₂ O ₃ to achieve low interfacial trap density and high-performance self-aligned inversion-channel p-metal-oxide-semiconductor field-effect-transistors. <i>Applied Physics Letters</i> , 2014, 105, .	3.3	31
50	Carrier dynamics in dilute II-VI oxide highly mismatched alloys. <i>Proceedings of SPIE</i> , 2014, , .	0.8	0
51	Gate leakage current induced trapping in AlGaIn/GaN Schottky-gate HFETs and MISHFETs. <i>Nanoscale Research Letters</i> , 2014, 9, 474.	5.7	11
52	Investigation of C-terminal domain of SARS nucleocapsid protein-Duplex DNA interaction using transistors and binding-site models. <i>Sensors and Actuators B: Chemical</i> , 2014, 193, 334-339.	7.8	6
53	High Breakdown Voltage and Low Thermal Effect Micromachined AlGaIn/GaN HEMTs. <i>IEEE Transactions on Device and Materials Reliability</i> , 2014, 14, 726-731.	2.0	8
54	Optical and electrical properties of ZnSeO alloys grown by plasma-assisted molecular beam epitaxy. <i>Journal of Crystal Growth</i> , 2013, 378, 180-183.	1.5	11

#	ARTICLE	IF	CITATIONS
55	Sb-based semiconductors for low power electronics. Journal of Materials Chemistry C, 2013, 1, 4616.	5.5	21
56	High performance InAs/AlSb HEMT with refractory iridium Schottky gate metal. , 2013, , .		0
57	AlGaIn/GaN high electron mobility transistors for protein-peptide binding affinity study. Biosensors and Bioelectronics, 2013, 41, 717-722.	10.1	34
58	In-Plane Gate Transistors for Photodetector Applications. IEEE Electron Device Letters, 2013, 34, 780-782.	3.9	5
59	Identification of the Amount of Binding Sites and Dissociation Constants of a Ligand-Receptor Complex Using AlGaIn/GaN High Electron Mobility Transistors. ACS Symposium Series, 2013, , 63-76.	0.5	0
60	InGaSb/AlSb p-channel HFETs with hydrogen plasma treatment. Electronics Letters, 2013, 49, 499-500.	1.0	1
61	Surface Passivation of GaSb(100) Using Molecular Beam Epitaxy of Y_2O_3 and Atomic Layer Deposition of Al_2O_3 : A Comparative Study. Applied Physics Express, 2013, 6, 121201.	2.4	13
62	Detection of Severe Acute Respiratory Syndrome (SARS) Coronavirus Nucleocapsid Protein Using AlGaIn/GaN High Electron Mobility Transistors. ECS Transactions, 2013, 50, 239-243.	0.5	11
63	Memory device application of wide-channel in-plane gate transistors with type-II GaAsSb-capped InAs quantum dots. Applied Physics Letters, 2013, 103, 143502.	3.3	9
64	Band alignment tuning of InAs quantum dots with a thin AlGaAsSb capping layer. Applied Physics Letters, 2013, 102, .	3.3	7
65	Characteristics of InAs/AlSb high electron mobility transistors grown on Si using a GaAsSb step-graded buffer layer. Journal of Vacuum Science and Technology B: Nanotechnology and Microelectronics, 2013, 31, 061207.	1.2	1
66	Efficiency improvement of GaN light emitting diodes on Si by double island growth method. , 2013, , .		0
67	Human immunodeficiency virus drug development assisted with AlGaIn/GaN high electron mobility transistors and binding-site models. Applied Physics Letters, 2013, 102, 173704.	3.3	16
68	Growth and Characterization of Crack-Free Semi-Polar (1-101) GaN on 7° -off (001) Si Substrates by Metal-Organic Chemical Vapor Deposition. ECS Journal of Solid State Science and Technology, 2013, 2, N3001-N3005.	1.8	5
69	Effect of Gate Length on Device Performances of AlSb/InAs High Electron Mobility Transistors Fabricated Using BCl_3 Dry Etching. Japanese Journal of Applied Physics, 2012, 51, 060202.	1.5	1
70	Gate Stack Engineering and Thermal Treatment on Electrical and Interfacial Properties of Ti/Pt/HfO_2 /InAs p-MOS Capacitors. Active and Passive Electronic Components, 2012, 2012, 1-6.	0.3	1
71	Carrier Transport Study of TMIIn-Treated InGaN LEDs by Using Quantum Efficiency and Time-Resolved Electro-Luminescence Measurements. Journal of the Electrochemical Society, 2012, 159, H225-H229.	2.9	7
72	Characteristic improvements of vertically aligned columnar quantum dot solar cell with a GaAsSb capping layer. , 2012, , .		0

#	ARTICLE	IF	CITATIONS
73	Investigation of the binding affinity of C-terminal domain of SARS coronavirus nucleocapsid protein to nucleotide using AlGaIn/GaN high electron mobility transistors. , 2012, , .		1
74	Elucidation of dissociation constants and binding sites of antibody-antigen complex using AlGaIn/GaN high electron mobility transistors. , 2012, , .		0
75	Temperature-dependent decay dynamics in highly mismatched ZnSe _{1-x} Te _x alloy. Applied Physics Letters, 2012, 100, .	3.3	4
76	Device Characteristics of InGaSb/AlSb High-Hole-Mobility FETs. IEEE Electron Device Letters, 2012, 33, 964-966.	3.9	11
77	Improving the characteristics of intermediate-band solar cell devices using a vertically aligned InAs/GaAsSb quantum dot structure. Solar Energy Materials and Solar Cells, 2012, 105, 237-241.	6.2	51
78	A gold-free fully copper metalized AlGaIn/GaN power HEMTs on Si substrate. Microelectronics Reliability, 2012, 52, 2556-2560.	1.7	3
79	Photomodulation reflectance study of temperature dependence of the band gap of ZnSe _{1-x} O _x . Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 187-189.	0.8	6
80	A 600 V AlGaIn/GaN Schottky barrier diode on silicon substrate with fast reverse recovery time. Physica Status Solidi C: Current Topics in Solid State Physics, 2012, 9, 949-952.	0.8	16
81	Broadband terahertz ultrasonic transducer based on a laser-driven piezoelectric semiconductor superlattice. Ultrasonics, 2012, 52, 1-4.	3.9	26
82	Propagation, Resonance, and Radiation on Terahertz Optoelectronic Integrated Circuits. IEEE Photonics Journal, 2012, 4, 699-706.	2.0	3
83	Efficiency Enhancement of InGaIn LEDs With an n-Type AlGaIn/GaN/InGaIn Current Spreading Layer. IEEE Electron Device Letters, 2011, 32, 1409-1411.	3.9	17
84	High-Performance AlGaIn/GaN Schottky Diodes With an AlGaIn/AlN Buffer Layer. IEEE Electron Device Letters, 2011, 32, 1519-1521.	3.9	51
85	Effects of GaAsSb capping layer thickness on the optical properties of InAs quantum dots. Applied Physics Letters, 2011, 99, 073108.	3.3	31
86	Growth of crack-free semi-polar (1-101) GaN on a 7Å°-off (001) Si substrate by metal-organic chemical vapor deposition. , 2011, , .		1
87	Electrical properties of In-doped ZnO films grown by plasma-assisted molecular beam epitaxy on GaN(0001) template. Proceedings of SPIE, 2011, , .	0.8	0
88	Optical properties of InGaIn/GaN multiple quantum wells with trimethylindium treatment during growth interruption. Journal of Crystal Growth, 2011, 325, 41-45.	1.5	8
89	High optical property vertically aligned InAs quantum dot structures with GaAsSb overgrown layers. Journal of Crystal Growth, 2011, 323, 164-166.	1.5	18
90	The impact of trimethylindium treatment time during growth interruption on the carrier dynamics of InGaIn/GaN multiple quantum wells. Thin Solid Films, 2011, 519, 6092-6096.	1.8	12

#	ARTICLE	IF	CITATIONS
91	Terahertz photonic transmitters with a high-gain open-ended rampart slot array antenna. , 2010, , .		1
92	DC Characteristics of InAlAs/InGaAsSb/InGaAs Double Heterojunction Bipolar Transistors. IEEE Transactions on Electron Devices, 2010, 57, 3327-3332.	3.0	4
93	Challenges and Opportunities in GaN and ZnO Devices and Materials [Scanning the Issue]. Proceedings of the IEEE, 2010, 98, 1113-1117.	21.3	8
94	Characterization and Comparison of GaAs/AlGaAs Uni-Traveling Carrier and Separated-Transport-Recombination Photodiode Based High-Power Sub-THz Photonic Transmitters. IEEE Journal of Quantum Electronics, 2010, 46, 19-27.	1.9	9
95	Extremely High Saturation Current-Bandwidth Product Performance of a Near-Ballistic Uni-Traveling-Carrier Photodiode With a Flip-Chip Bonding Structure. IEEE Journal of Quantum Electronics, 2010, 46, 80-86.	1.9	64
96	Tailoring of the Wave Function Overlaps and the Carrier Lifetimes in InAs/GaAs $_{1-x}$ Sb $_x$ Type-II Quantum Dots. Physica E: Low-Dimensional Systems and Nanostructures, 2010, 42, 2524-2528.	2.7	4
97	Fabrication study of AlN solar-blind (280nm) MSM photodetectors grown by low-temperature deposition. Physica Status Solidi (A) Applications and Materials Science, 2010, 207, 224-228.	1.8	12
98	Temperature-Dependent Characteristics of a GaN/InGaN/ZnO Heterojunction Bipolar Transistor. Journal of the Electrochemical Society, 2010, 157, H381.	2.9	8
99	N ^{<sup>+</sup>} -InGaAs/InAlAs recessed gates for InAs/AlSb HFET development. , 2010, , .		0
100	Spectroscopic ellipsometric analysis of ZnSe $_{1-x}$ O $_x$ layers with different O compositions. Journal of Applied Physics, 2010, 108, .	2.5	2
101	Photoluminescence of self-assembled InAs quantum dots embedded in photonic crystal nanocavities with shifted air holes. Nanotechnology, 2010, 21, 055201.	2.6	1
102	Site-controlled self-assembled InAs quantum dots grown on GaAs substrates. Nanotechnology, 2010, 21, 295304.	2.6	4
103	Effects of Lens Shape on GaN Grown on Microlens Patterned Sapphire Substrates by Metallorganic Chemical Vapor Deposition. Journal of the Electrochemical Society, 2010, 157, H304.	2.9	30
104	Low Surface Recombination in InAlAs/InGaAsSb/InGaAs Double Heterojunction Bipolar Transistors. IEEE Electron Device Letters, 2010, 31, 1401-1403.	3.9	4
105	Room-temperature operation type-II GaSb/GaAs quantum-dot infrared light-emitting diode. Applied Physics Letters, 2010, 96, .	3.3	55
106	Room-temperature operation type-II GaSb/GaAs quantum-dot infrared light-emitting diode. , 2010, , .		1
107	Ti- and Pt-based Schottky gates for InGaSb p-channel HFET development. , 2010, , .		0
108	DC and RF characteristics of InAs-channel MOS-MODFETs using PECVD SiO $_2$ as gate dielectrics. , 2010, , .		0

#	ARTICLE	IF	CITATIONS
109	Characterization of InAlAs/In _{0.25} Ga _{0.75} As/In _{0.72} Sb _{0.28} /InGaAs double heterojunction bipolar transistors. , 2010, , .		
110	Origins of nonzero multiple photon emission probability from single quantum dots embedded in photonic crystal nanocavities. Applied Physics Letters, 2009, 94, 163111.	3.3	3
111	Photogeneration of coherent shear phonons in orientated wurtzite semiconductors by piezoelectric coupling. Physical Review B, 2009, 80, .	3.2	29
112	Effects of thermal annealing on the emission properties of type-II InAs/GaAsSb quantum dots. Applied Physics Letters, 2009, 94, 053101.	3.3	40
113	Electrically manipulating the optical sensitivity function in quantum wells for nanoacoustic wave detection. Applied Physics Letters, 2009, 95, 143108.	3.3	2
114	InAlAs/InGaAsSb/InGaAs double heterojunction bipolar transistors with high current gain and low base sheet resistance. , 2009, , .		0
115	Proton irradiation effects on Sb-based heterojunction bipolar transistors. Journal of Vacuum Science & Technology B, 2009, 27, L33.	1.3	1
116	The Structure of GaN-Based Transverse Junction Blue LED Array for Uniform Distribution of Injected Current/Carriers. IEEE Journal of Selected Topics in Quantum Electronics, 2009, 15, 1292-1297.	2.9	11
117	Exciton fine structures and energy transfer in single InGaAs quantum dot molecules. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, 860-863.	0.8	1
118	Time-resolved photoluminescence of type-II InAs/GaAs quantum dots covered by a thin GaAs _x Sb _x layer. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, 1449-1452.	0.8	5
119	Investigations of photo-assisted conductive atomic force microscopy on III-nitrides. Microelectronics Journal, 2009, 40, 353-356.	2.0	1
120	The Monolithic Integration of GaAs-AlGaAs-Based Unitraveling-Carrier Photodiodes With Zn-Diffusion Vertical-Cavity Surface-Emitting Lasers With Extremely High Data Rate/Power Consumption Ratios. IEEE Photonics Technology Letters, 2009, 21, 1444-1446.	2.5	6
121	Metal-oxide-HEMT on 6.1 \times antimonides. , 2009, , .		1
122	An electrically driven quasi-L2 photonic crystal nano-cavity with a small mode volume. , 2009, , .		0
123	Low-leakage InAs/AlSb HEMT with high FT-LG product. , 2009, , .		2
124	Low-resistance smooth-surface Ti/Al/Cr/Mo/Au n-type Ohmic contact to AlGaN/GaN heterostructures. Applied Physics Letters, 2009, 94, .	3.3	19
125	Improved surface morphology and edge definition for ohmic contacts to AlGaN/GaN heterostructures. Proceedings of SPIE, 2009, , .	0.8	2
126	Growth of high quality AlN on sapphire by using a low-temperature AlN interlayer. , 2009, , .		3

#	ARTICLE	IF	CITATIONS
127	Polarization-Enhanced Mg Doping in InGaN/GaN Superlattice for Green Light-Emitting Diodes. , 2009, , .		3
128	Bias-Controlled Coherent Acoustic Phonon Generation in InGaN/GaN Multiple-Quantum-Wells Light Emitting Diodes. , 2009, , .		0
129	Luminescence mechanism and carrier dynamic studies of InGaN-based dichromatic light emitting diodes with ultraviolet and blue emissions. Thin Solid Films, 2008, 517, 909-915.	1.8	9
130	Site-controlled InGaAs quantum dots grown on a GaAs multi-faceted microstructure for single photon emissions. Physica Status Solidi C: Current Topics in Solid State Physics, 2008, 5, 2713-2715.	0.8	3
131	Highly Directed Radiation Pattern From a THz Photonic Transmitter With a Two-Dimensional Rampart Slot Array Antenna. IEEE Photonics Technology Letters, 2008, 20, 1042-1044.	2.5	1
132	Enhanced Normal-Incident Absorption of Quantum-Dot Infrared Photodetectors With Smaller Quantum Dots. IEEE Photonics Technology Letters, 2008, 20, 1240-1242.	2.5	9
133	Light Output Enhancement of InGaN Light-Emitting Diodes Grown on Masklessly Etched Sapphire Substrates. IEEE Photonics Technology Letters, 2008, 20, 1621-1623.	2.5	27
134	Ultra low turn-on voltage and high-current InP DHBT with a pseudomorphic $\text{In}_{0.37}\text{Ga}_{0.63}\text{As}_{0.89}\text{Sb}_{0.11}$ base. , 2008, , .		0
135	High extractive single-photon emissions from InGaAs quantum dots on a GaAs pyramid-like multifaceted structure. Nanotechnology, 2008, 19, 045714.	2.6	6
136	Growth and characterization of crack-free semipolar $\{1-101\}\text{InGaN}/\text{GaN}$ multiple-quantum well on V-grooved (001)Si substrates. Applied Physics Letters, 2008, 92, .	3.3	17
137	Low Turn-On Voltage and High-Current $\text{In}_{0.37}\text{Ga}_{0.63}\text{As}_{0.89}\text{Sb}_{0.11}/\text{In}_{0.53}\text{Ga}_{0.47}\text{As}$ Double Heterojunction Bipolar Transistors. IEEE Electron Device Letters, 2008, 29, 655-657.		17
138	Nonresonant carrier transfer in single InGaAs/GaAs quantum dot molecules. Physical Review B, 2008, 77, .	3.2	14
139	Carrier dynamics of type-II InAs/GaAs quantum dots covered by a thin GaAs \times Sb layer. Applied Physics Letters, 2008, 93, .	3.3	41
140	Enhancing the quantum efficiency of InGaN green light-emitting diodes by trimethylindium treatment. Applied Physics Letters, 2008, 92, 161113.	3.3	25
141	DC and RF characteristics of type II lineup InAs/AlSb HFETs. , 2008, , .		0
142	Highly-directed terahertz photonic transmitter by using the design of planar antenna arrays. , 2008, , .		0
143	Enhancing the light extraction of InGaN light-emitting diodes by patterning the dicing streets. , 2008, , .		0
144	Epitaxial lateral overgrowth of GaN on AlGaN/(111)Si micropillar array fabricated by polystyrene microsphere lithography. , 2008, , .		2

#	ARTICLE	IF	CITATIONS
145	Emission Intensity Improvement of InGaN Ultraviolet Light-Emitting Diodes Grown on Wet-Etched Sapphire Substrates. , 2007, , .		0
146	Single photon emission from an InGaAs quantum dot precisely positioned on a nanoplane. Applied Physics Letters, 2007, 90, 073105.	3.3	27
147	Crack-free GaN grown on AlGaIn \cdot (111)Si micropillar array fabricated by polystyrene microsphere lithography. Applied Physics Letters, 2007, 91, 261910.	3.3	13
148	DC Characteristics of GaAsSb/InGaAs Type-II Heterojunction Bipolar Transistor. Indium Phosphide and Related Materials Conference (IPRM), IEEE International Conference on, 2007, , .	0.0	0
149	Light output improvement of InGaN ultraviolet light-emitting diodes by using wet-etched stripe-patterned sapphire substrates. Journal of Applied Physics, 2007, 102, 084503.	2.5	35
150	Narrow-band detection of propagating coherent acoustic phonons in piezoelectric InGaIn \cdot GaN multiple-quantum wells. Applied Physics Letters, 2007, 91, 133101.	3.3	9
151	Optical piezoelectric transducer based nanoultrasonics. , 2007, , .		0
152	Emission Intensity Improvement of InGaN Ultraviolet Light-Emitting Diodes Grown on Wet-Etched Sapphire Substrates. , 2007, , .		0
153	Anharmonic decay of subterahertz coherent acoustic phonons in GaN. Applied Physics Letters, 2007, 90, 041902.	3.3	22
154	High Current and Low Turn-On Voltage InAlAs/InGaAsSb/InGaAs Heterojunction Bipolar Transistor. Indium Phosphide and Related Materials Conference (IPRM), IEEE International Conference on, 2007, , .	0.0	1
155	Enhancing the optical properties of InAs quantum dots by an InAlAsSb overgrown layer. Applied Physics Letters, 2007, 91, 153106.	3.3	14
156	InGaAsSb/InP Double Heterojunction Bipolar Transistors Grown by Solid-Source Molecular Beam Epitaxy. IEEE Electron Device Letters, 2007, 28, 679-681.	3.9	15
157	Single Photon Emission From an InGaAs Quantum Dot Precisely Positioned on a Nano-Plane. Indium Phosphide and Related Materials Conference (IPRM), IEEE International Conference on, 2007, , .	0.0	0
158	High Optical Quality of InAs Quantum Dots with an InAlAsSb Strain-Reducing Layer. Indium Phosphide and Related Materials Conference (IPRM), IEEE International Conference on, 2007, , .	0.0	0
159	Simulation and fabrication of high voltage AlGaIn/GaN based Schottky diodes with field plate edge termination. Microelectronic Engineering, 2007, 84, 2907-2915.	2.4	15
160	Carrier transport studies of dichromatic InGaIn-based LEDs with spacer bandgap dependence. Physica Status Solidi C: Current Topics in Solid State Physics, 2007, 4, 2716-2719.	0.8	1
161	Spatial manipulation of nanoacoustic waves with nanoscale spot sizes. Nature Nanotechnology, 2007, 2, 704-708.	31.5	80
162	Low-density quantum dots embedded in photonic-crystal nanocavities for single-photon generations. AIP Conference Proceedings, 2007, , .	0.4	0

#	ARTICLE	IF	CITATIONS
163	Enhancing luminescence efficiency of InAs quantum dots at 1.5 μ m using a carrier blocking layer. Applied Physics Letters, 2006, 89, 053110.	3.3	7
164	Optical properties of indium nitride nanorods prepared by chemical-beam epitaxy. Nanotechnology, 2006, 17, 3930-3932.	2.6	29
165	Catalyst-free growth of indium nitride nanorods by chemical-beam epitaxy. Applied Physics Letters, 2006, 88, 233111.	3.3	27
166	Thermal stability improvement by using Pd \cdot NiO \cdot Al \cdot Ti \cdot Au reflective ohmic contacts to p-GaN for flip-chip ultraviolet light-emitting diodes. Applied Physics Letters, 2006, 88, 062113.	3.3	5
167	Terahertz Microchip for Illicit Drug Detection. IEEE Photonics Technology Letters, 2006, 18, 2254-2256.	2.5	44
168	Pinholelike defects in multistack 1.3 μ m InAs quantum dot laser. Journal of Applied Physics, 2006, 99, 114514.	2.5	16
169	Frequency tunability of terahertz photonic transmitters. Applied Physics Letters, 2006, 88, 093501.	3.3	8
170	Laser emission from GaN photonic crystals. Applied Physics Letters, 2006, 89, 071116.	3.3	31
171	Efficient Single-Photon Sources Based on Low-Density Quantum Dots in Photonic-Crystal Nanocavities. Physical Review Letters, 2006, 96, 117401.	7.8	244
172	Growth of low density InGaAs quantum dots for single photon sources by metal \cdot organic chemical vapour deposition. Nanotechnology, 2006, 17, 512-515.	2.6	11
173	1.32 μ m InAs \cdot GaAs quantum-dot resonant-cavity light-emitting diodes grown by metalorganic chemical vapor deposition. Journal of Vacuum Science & Technology B, 2006, 24, 1922.	1.3	0
174	Enhanced thermal stability and emission intensity of InAs quantum dots covered by an InGaAsSb strain-reducing layer. Applied Physics Letters, 2006, 89, 243103.	3.3	26
175	Two-dimensional nanoultrasonic imaging by using acoustic nanowaves. Applied Physics Letters, 2006, 89, 043106.	3.3	34
176	Characterizing the nanoacoustic superlattice in a phonon cavity using a piezoelectric single quantum well. Applied Physics Letters, 2006, 89, 143103.	3.3	17
177	Anharmonic decay of longitudinal coherent acoustic phonons in GaN : Confirmation of Herring's theory in the sub-THz regime. , 2006, , .		0
178	Generation, detection, and propagation of nano-acoustic waves in piezoelectric semiconductors (Invited Paper). , 2005, , .		0
179	Improvement of Mesa-Sidewall Leakage Current Using Benzocyclobuten Sidewall Process in InGaAs/InP MSM Photodetector. Japanese Journal of Applied Physics, 2005, 44, 2586-2587.	1.5	3
180	Selective growth of InAs quantum dots on patterned GaAs. Journal of Vacuum Science & Technology an Official Journal of the American Vacuum Society B, Microelectronics Processing and Phenomena, 2005, 23, 262.	1.6	7

#	ARTICLE	IF	CITATIONS
181	InGaAsNâ•GaAs quantum-well lasers using two-step and nitride passivation growth. Applied Physics Letters, 2005, 87, 091115.	3.3	1
182	Optical properties of InAs quantum dots with InAlAsâ•InGaAs composite matrix. Journal of Applied Physics, 2005, 97, 024312.	2.5	21
183	Ultrafast carrier dynamics in an InGaN thin film. Journal of Applied Physics, 2005, 97, 033704.	2.5	9
184	Generation of frequency-tunable nanoacoustic waves by optical coherent control. Applied Physics Letters, 2005, 87, 093114.	3.3	23
185	Carrier dynamics studies of InGaN-based UV-blue two-color LEDs. , 2005, , .		0
186	1.55Î¼m emission from InAs quantum dots grown on GaAs. Applied Physics Letters, 2005, 87, 151903.	3.3	19
187	Broadband-response and frequency-tunable terahertz photonic transmitters with high efficiency. , 2005, , .		1
188	Optical piezoelectric transducer for nano-ultrasonics. IEEE Transactions on Ultrasonics, Ferroelectrics, and Frequency Control, 2005, 52, 1404-1414.	3.0	31
189	Investigation of layered structure SAW devices fabricated using low temperature grown AlN thin film on GaN/sapphire. IEEE Transactions on Ultrasonics, Ferroelectrics, and Frequency Control, 2005, 52, 923-926.	3.0	12
190	Single photon sources based on single InGaAs quantum dots. , 2005, , .		0
191	Freezing phase scheme for fast adaptive control and its application to characterization of femtosecond coherent optical pulses reflected from semiconductor saturable absorber mirrors. Journal of the Optical Society of America B: Optical Physics, 2005, 22, 1134.	2.1	6
192	Low resistance WSix-based ohmic contacts on n-type GaN. Journal of Applied Physics, 2005, 98, 013712.	2.5	4
193	Focused ion beam micromilling of GaN photonic devices with gas enhanced etching techniques. , 2005, , 423-426.		0
194	Nanostructures and carrier localization behaviors of green-luminescence InGaN/GaN quantum-well structures of various silicon-doping conditions. Applied Physics Letters, 2004, 84, 2506-2508.	3.3	59
195	High-reflectivity Pdâ•Niâ•Alâ•Tiâ•Au ohmic contacts to p-type GaN for ultraviolet light-emitting diodes. Applied Physics Letters, 2004, 85, 2797-2799.	3.3	14
196	On the origin of spin loss in GaMnN/InGaN light-emitting diodes. Applied Physics Letters, 2004, 84, 2599-2601.	3.3	36
197	Luminescence efficiency of InGaN multiple-quantum-well ultraviolet light-emitting diodes. Applied Physics Letters, 2004, 84, 5249-5251.	3.3	42
198	Electroreflectance study on the polarization field in InGaN/AlInGaN multiple quantum wells. Applied Physics Letters, 2004, 84, 1114-1116.	3.3	26

#	ARTICLE	IF	CITATIONS
199	Reflection property of nano-acoustic wave at the air-GaN interface. Applied Physics Letters, 2004, 85, 4735-4737.	3.3	14
200	MgO/p-GaN enhancement mode metal-oxide semiconductor field-effect transistors. Applied Physics Letters, 2004, 84, 2919-2921.	3.3	104
201	The Microwave Power Performance Comparisons of Al _x Ga _{1-x} As/In _{0.15} Ga _{0.85} As ($x=0.3, 0.5, 0.7, 1.0$) Doped-Channel HFETs. IEEE Transactions on Electron Devices, 2004, 51, 156-158.	3.0	2
202	AlGaIn/GaN HEMT based liquid sensors. Solid-State Electronics, 2004, 48, 351-353.	1.4	68
203	1.3 μ m InAs/GaAs quantum dots directly capped with GaAs grown by metal-organic chemical vapor deposition. Journal of Crystal Growth, 2004, 264, 128-133.	1.5	2
204	Low Damage, Cl ₂ -Based Gate Recess Etching for 0.3- μ m Gate-Length AlGaIn/GaN HEMT Fabrication. IEEE Electron Device Letters, 2004, 25, 52-54.	3.9	31
205	Low- κ BCB Passivation on AlGaIn-GaN HEMT Fabrication. IEEE Electron Device Letters, 2004, 25, 763-765.	3.9	16
206	InGaIn-GaN MQW LEDs With Current Blocking Layer Formed by Selective Activation. IEEE Electron Device Letters, 2004, 25, 384-386.	3.9	17
207	Nano-ultrasonics: science and technology. , 2004, 5352, 101.		2
208	Mechanisms for photon-emission enhancement with silicon doping in InGaIn/GaN quantum-well structures. Journal of Electronic Materials, 2003, 32, 375-381.	2.2	13
209	Er diffusion into gallium nitride. Solid-State Electronics, 2003, 47, 529-531.	1.4	2
210	Diffusion mechanism and photoluminescence of erbium in GaN. Optical Materials, 2003, 24, 515-518.	3.6	7
211	Characteristics of amplified spontaneous emission of high indium content InGaIn/GaN quantum wells with various silicon doping conditions. Physica Status Solidi C: Current Topics in Solid State Physics, 2003, 0, 2670-2673.	0.8	0
212	High-brightness inverted InGaIn-GaN multiple-quantum-well light-emitting diodes without a transparent conductive layer. IEEE Electron Device Letters, 2003, 24, 156-158.	3.9	22
213	An In _{0.6} Ga _{0.4} As/GaAs quantum dot infrared photodetector with operating temperature up to 260K. , 2003, 5074, 677.		1
214	Transport in a gated Al _{0.18} Ga _{0.82} N/GaN electron system. Journal of Applied Physics, 2003, 94, 3181-3184.	2.5	32
215	In _{0.6} Ga _{0.4} As/GaAs quantum-dot infrared photodetector with operating temperature up to 260 K. Applied Physics Letters, 2003, 82, 1986-1988.	3.3	130
216	Current-voltage and reverse recovery characteristics of bulk GaN p-i-n rectifiers. Applied Physics Letters, 2003, 83, 2271-2273.	3.3	22

#	ARTICLE	IF	CITATIONS
217	Response to "Comment on "AlN/GaN double-barrier resonant tunneling diodes grown by rf-plasma-assisted molecular-beam epitaxy" [Appl. Phys. Lett. 83, 3626 (2003)]. Applied Physics Letters, 2003, 83, 3628-3628.		17
218	Quantum dot formation with silicon doping in InGaN/GaN quantum well structures and its implications in radiative mechanisms. , 2003, 4999, 518.		0
219	GaN AND AlGaIn HIGH VOLTAGE POWER RECTIFIERS. , 2003, , 125-171.		0
220	Multiple-component photoluminescence decay caused by carrier transport in InGaN/GaN multiple quantum wells with indium aggregation structures. Applied Physics Letters, 2002, 80, 4375-4377.	3.3	43
221	AlN/GaN double-barrier resonant tunneling diodes grown by rf-plasma-assisted molecular-beam epitaxy. Applied Physics Letters, 2002, 81, 1729-1731.	3.3	120
222	InAs/GaAs quantum dot lasers with InGaP cladding layer grown by solid-source molecular-beam epitaxy. Applied Physics Letters, 2002, 80, 535-537.	3.3	15
223	Localized and quantum-well state excitons in AlInGaIn laser-diode structure. Physical Review B, 2002, 66, .	3.2	8
224	Investigation of InAs/GaAs quantum-dot infrared photodetector with In _{0.5} Ga _{0.5} P dark current blocking layer. Electronics Letters, 2002, 38, 1374.	1.0	6
225	Dynamic carrier relaxation in InGaN/GaN multiple quantum well structures. , 2002, 4643, 169.		0
226	Direct measurement of piezoelectric field in In _{0.23} Ga _{0.77} N/GaN multiple quantum wells by electrotransmission spectroscopy. Journal of Applied Physics, 2002, 91, 531.	2.5	59
227	Effect of composition inhomogeneity on the photoluminescence of InGaN/GaN multiple quantum wells upon thermal annealing. Applied Physics Letters, 2002, 80, 1138-1140.	3.3	24
228	Impact of localized states on the recombination dynamics in InGaN/GaN quantum well structures. Journal of Applied Physics, 2002, 92, 4441-4448.	2.5	100
229	Breakdown voltage and reverse recovery characteristics of free-standing GaN Schottky rectifiers. IEEE Transactions on Electron Devices, 2002, 49, 32-36.	3.0	88
230	Thermal annealing effects on stimulated emission of high-indium-content InGaN/GaN single quantum well structure. Solid-State Electronics, 2002, 46, 1123-1126.	1.4	4
231	Interdiffusion of In and Ga in InGaN/GaN multiple quantum wells. Applied Physics Letters, 2001, 78, 314-316.	3.3	75
232	Device characteristics of the GaN/InGaN-doped channel HFETs. IEEE Electron Device Letters, 2001, 22, 501-503.	3.9	24
233	Carrier dynamics in InGaN/GaN multiple quantum well structures. , 2001, 4594, 197.		2
234	Schottky rectifiers fabricated on free-standing GaN substrates. Solid-State Electronics, 2001, 45, 405-410.	1.4	36

#	ARTICLE	IF	CITATIONS
235	Improvement of diodes performance with a multiple-pair buffer layer by MOCVD. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2001, 82, 253-255.	3.5	1
236	GaN electronics for high power, high temperature applications. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2001, 82, 227-231.	3.5	95
237	Two-Component Photoluminescence Decay in InGaN/GaN Multiple Quantum Well Structures. Physica Status Solidi (B): Basic Research, 2001, 228, 121-124.	1.5	9
238	Activation of p-Type GaN with Irradiation of the Second Harmonics of a Q-Switched Nd : YAG Laser. Physica Status Solidi (B): Basic Research, 2001, 228, 357-360.	1.5	0
239	Improved electroluminescence of InAs quantum dots with strain reducing layer. Journal of Crystal Growth, 2001, 227-228, 1044-1048.	1.5	8
240	Comparison of GaN p-i-n and Schottky rectifier performance. IEEE Transactions on Electron Devices, 2001, 48, 407-411.	3.0	71
241	A comparative study of the passivation films on AlGaAs/GaAs heterojunction diodes and bipolar transistors. IEEE Transactions on Electron Devices, 2001, 48, 185-189.	3.0	3
242	Laser-Induced Activation of p-Type GaN with the Second Harmonics of a Nd:YAG Laser. Japanese Journal of Applied Physics, 2001, 40, 2143-2145.	1.5	11
243	<title>Indium segregation in InGaN/GaN quantum well structures</title>. , 2001, , .		1
244	SiO ₂ /Gd ₂ O ₃ /GaN Metal Oxide Semiconductor Field Effect Transistors. Journal of the Electrochemical Society, 2001, 148, G303.	2.9	35
245	Effect of thermal annealing on high indium content InGaN/GaN single quantum well structures. Journal of Applied Physics, 2001, 89, 5465-5468.	2.5	23
246	Temperature dependence of the radiative recombination zone in InGaN/GaN multiple quantum well light-emitting diodes. Journal of Applied Physics, 2001, 89, 6554-6556.	2.5	42
247	Quantum-confined Stark shift in electroreflectance of InAs/InxGa _{1-x} As self-assembled quantum dots. Applied Physics Letters, 2001, 78, 1760-1762.	3.3	34
248	Vertical and lateral GaN rectifiers on free-standing GaN substrates. Applied Physics Letters, 2001, 79, 1555-1557.	3.3	63
249	AlGaN/InGaN Heterostructure Field Effect Transistors Grown on Sapphire by Metal-Organic Chemical Vapor Deposition. Materials Research Society Symposia Proceedings, 2000, 639, 11111.	0.1	0
250	Effects of Spacer Thickness on the Performance of InGaAs/GaAs Quantum Dot Lasers. Materials Research Society Symposia Proceedings, 2000, 642, 3211.	0.1	0
251	Electrical and optical characteristics of the GaN light-emitting diodes with multiple-pair buffer layer. Solid-State Electronics, 2000, 44, 1483-1486.	1.4	8
252	Temperature dependence of GaN high breakdown voltage diode rectifiers. Solid-State Electronics, 2000, 44, 613-617.	1.4	32

#	ARTICLE	IF	CITATIONS
253	Surface and bulk leakage currents in high breakdown GaN rectifiers. Solid-State Electronics, 2000, 44, 619-622.	1.4	29
254	MBE growth and characterisation of InGaAs quantum dot lasers. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2000, 75, 121-125.	3.5	5
255	High voltage GaN Schottky rectifiers. IEEE Transactions on Electron Devices, 2000, 47, 692-696.	3.0	77
256	Photocurrent studies of the carrier escape process from InAs self-assembled quantum dots. Physical Review B, 2000, 62, 6959-6962.	3.2	81
257	Stimulated emission study of InGaN/GaN multiple quantum well structures. Applied Physics Letters, 2000, 76, 318-320.	3.3	13
258	Electron distribution and level occupation in an ensemble of In _x Ga _{1-x} As/GaAs self-assembled quantum dots. Physical Review B, 2000, 62, 13040-13047.	3.2	21
259	Optical pumping spectra for In _x Ga _{1-x} N/GaN multiple-quantum-well structures with indium content $x > 0.35$. , 2000, 4078, 28.		0
260	Stimulated-emission spectra of high-indium-content InGaN/GaN multiple-quantum-well structures. Applied Physics Letters, 2000, 77, 3758-3760.	3.3	27
261	Dependence of composition fluctuation on indium content in InGaN/GaN multiple quantum wells. Applied Physics Letters, 2000, 77, 2988-2990.	3.3	223
262	Gd ₂ O ₃ /GaN metal-oxide-semiconductor field-effect transistor. Applied Physics Letters, 2000, 77, 3230-3232.	3.3	96
263	Tuning the energy levels of self-assembled InAs quantum dots by rapid thermal annealing. Applied Physics Letters, 2000, 76, 691-693.	3.3	80
264	Matrix dependence of strain-induced wavelength shift in self-assembled InAs quantum-dot heterostructures. Applied Physics Letters, 2000, 76, 1567-1569.	3.3	73
265	Effects of thermal annealing on the luminescence and structural properties of high indium-content InGaN/GaN quantum wells. Applied Physics Letters, 2000, 76, 3902-3904.	3.3	54
266	Self-assembled In _{0.5} Ga _{0.5} As quantum-dot lasers with doped active region. IEEE Photonics Technology Letters, 2000, 12, 1123-1125.	2.5	7
267	Mechanism of luminescence in InGaN/GaN multiple quantum wells. Applied Physics Letters, 2000, 76, 3712-3714.	3.3	73
268	Excitation Density and Temperature Dependent Photoluminescence of InGaAs Self-Assembled Quantum Dots. Japanese Journal of Applied Physics, 1999, 38, 554-557.	1.5	15
269	Photoluminescence Characteristics of Self-Assembled In _{0.5} Ga _{0.5} As Quantum Dots on Vicinal GaAs Substrates. Japanese Journal of Applied Physics, 1999, 38, 550-553.	1.5	4
270	Room-Temperature Operation of In _{0.5} Ga _{0.5} As Quantum Dot Lasers Grown on Misoriented GaAs Substrates by Molecular Beam Epitaxy. Japanese Journal of Applied Physics, 1999, 38, 605-607.	1.5	8

#	ARTICLE	IF	CITATIONS
271	D.c. and microwave characteristics of In _{0.32} Al _{0.68} As/In _{0.33} Ga _{0.67} As heterojunction bipolar transistors grown on GaAs. <i>Solid-State Electronics</i> , 1999, 43, 463-468.	1.4	6
272	High performance phosphorus-free 1.3 μ m AlGaInAs/InP MQW lasers. <i>Journal of Crystal Growth</i> , 1999, 201-202, 923-926.	1.5	4
273	High characteristic temperature Be-doped In _{0.5} Ga _{0.5} As quantum dot lasers grown on GaAs substrates by molecular beam epitaxy. <i>Journal of Crystal Growth</i> , 1999, 201-202, 905-908.	1.5	2
274	Characterization of In _{0.5} Ga _{0.5} As quantum dot p-i-n structures with different matrices. <i>Journal of Crystal Growth</i> , 1999, 201-202, 1168-1171.	1.5	3
275	Strain-compensated 1.3- μ m AlGaInAs quantum-well lasers with multiquantum barriers at the cladding layers. <i>IEEE Photonics Technology Letters</i> , 1999, 11, 9-11.	2.5	2
276	Growth and Device Performance of GaN Schottky Rectifiers. <i>MRS Internet Journal of Nitride Semiconductor Research</i> , 1999, 4, 1.	1.0	21
277	Improved temperature characteristics of 1.55 μ m InAlGaAs quantum well lasers with multiquantum barrier at p-cladding layer. <i>Electronics Letters</i> , 1999, 35, 1255.	1.0	1
278	Matrix-dependent structural and photoluminescence properties of In _{0.5} Ga _{0.5} As quantum dots grown by molecular beam epitaxy. <i>Solid-State Electronics</i> , 1998, 42, 1331-1334.	1.4	12
279	GaAs MSM photodetectors with recessed anode and/or cathode. <i>IEEE Journal of Quantum Electronics</i> , 1998, 34, 811-816.	1.9	5
280	Temperature-dependent characteristics of 1.3- μ m AlGaInAs-InP lasers with multiquantum barriers at the guiding layers. <i>IEEE Photonics Technology Letters</i> , 1998, 10, 1700-1702.	2.5	10
281	Suppression of electron and hole leakage in 1.3 μ m AlGaInAs/InP quantum well lasers using multiquantum barrier. <i>Applied Physics Letters</i> , 1998, 72, 2090-2092.	3.3	15
282	Defects in metamorphic In _x Al _{1-x} As (x<0.4) epilayers grown on GaAs substrates. <i>Journal of Applied Physics</i> , 1997, 82, 210-213.	2.5	6
283	Studies of the effects of multi-stack multiquantum barrier on the properties of 1.3 μ m AlGaInAs/InP quantum well lasers. , 1997, , .		0
284	Overall performance improvement in GaAs MSM photodetectors by using recessed-cathode structure. <i>IEEE Photonics Technology Letters</i> , 1997, 9, 226-228.	2.5	7
285	Formation of self-organized In _{0.5} Ga _{0.5} As quantum dots on GaAs by molecular beam epitaxy. <i>Journal of Crystal Growth</i> , 1997, 175-176, 777-781.	1.5	24
286	Characteristics of a In _{0.52} (Al _x Ga _{1-x}) _{0.48} As/In _{0.53} Ga _{0.47} As(0 \leq x \leq 1) heterojunction and its application on HEMT's. <i>IEEE Transactions on Electron Devices</i> , 1997, 44, 708-714.	3.0	4
287	Porous silicon light-emitting diode with tunable color. <i>Solid-State Electronics</i> , 1997, 41, 757-759.	1.4	7
288	Material properties of compositional graded In _x Ga _{1-x} As and In _x Al _{1-x} As epilayers grown on GaAs substrates. <i>Journal of Applied Physics</i> , 1996, 79, 8367-8370.	2.5	62

#	ARTICLE	IF	CITATIONS
289	Reduction of hole transit time in GaAs MSM photodetectors by p-type /spl delta/-doping. IEEE Photonics Technology Letters, 1996, 8, 1525-1527.	2.5	8
290	Characteristics of multistack multiquantum barrier and its application to graded-index separate confinement heterostructure lasers. IEEE Journal of Quantum Electronics, 1996, 32, 442-447.	1.9	3
291	Theoretical study of the temperature dependence of 1.3- μ m AlGaInAs-InP multiple-quantum-well lasers. IEEE Journal of Quantum Electronics, 1996, 32, 2133-2138.	1.9	46
292	High-speed InGaAs metal-semiconductor-metal photodetectors with improved responsivity and process yield. Optical and Quantum Electronics, 1996, 28, 1327-1334.	3.3	14
293	Enhanced device performance by unstrained In/sub 0.3/Ga/sub 0.7/As/In/sub 0.29/Al/sub 0.71/As doped-channel FET on GaAs substrates. IEEE Electron Device Letters, 1996, 17, 410-412.	3.9	2
294	Double-heterojunction pseudomorphic AlGaAs/In _{0.15} Ga _{0.85} As HEMT and its short-channel effects. Solid-State Electronics, 1995, 38, 377-381.	1.4	3
295	High-performance large-area InGaAs MSM photodetectors with a pseudomorphic InGaP cap layer. IEEE Photonics Technology Letters, 1995, 7, 914-916.	2.5	11
296	High-responsivity InGaAs MSM photodetectors with semi-transparent Schottky contacts. IEEE Photonics Technology Letters, 1995, 7, 1333-1335.	2.5	20
297	Performance enhancement using WSix/ITO electrodes in InGaAs/InAlAs MSM photodetectors. Electronics Letters, 1995, 31, 1692-1694.	1.0	3
298	Characteristics of $\text{In}_{0.3}\text{Ga}_{0.7}\text{As}/\text{In}_{0.29}\text{Al}_{0.71}\text{As}$ Heterostructures Grown on GaAs Using InAlAs Buffers. Japanese Journal of Applied Physics, 1994, 33, L1574-L1576.	1.5	5
299	High uniformity of Al _{0.3} Ga _{0.7} As/In _{0.15} Ga _{0.85} As doped-channel structures grown by molecular beam epitaxy on GaAs substrates. Journal of Electronic Materials, 1994, 23, 675-679.	2.2	3
300	Resonant cavity-enhanced (RCE) photodetectors. IEEE Journal of Quantum Electronics, 1991, 27, 2025-2034.	1.9	308
301	Wavelength demultiplexing heterojunction phototransistor. Electronics Letters, 1990, 26, 1857.	1.0	21
302	Carrier effects on the excitonic absorption in GaAs quantum-well structures: Phase-space filling. Physical Review B, 1990, 42, 5147-5153.	3.2	73
303	Suppression of emitter size effect on the current-voltage characteristics of AlGaAs/GaAs heterojunction bipolar transistors. Applied Physics Letters, 1990, 56, 937-939.	3.3	17
304	Resonant cavity enhanced AlGaAs/GaAs heterojunction phototransistors with an intermediate InGaAs layer in the collector. Applied Physics Letters, 1990, 57, 750-752.	3.3	76
305	Breakdown behavior of GaAs/AlGaAs HBTs. IEEE Transactions on Electron Devices, 1989, 36, 2165-2172.	3.0	47
306	Infrared photoluminescence of InAs epilayers grown on GaAs and Si substrates. Journal of Applied Physics, 1989, 65, 4079-4081.	2.5	49

#	ARTICLE	IF	CITATIONS
307	On the microstructure and interfacial structure of InSb layers grown on GaAs(100) by molecular beam epitaxy. Philosophical Magazine A: Physics of Condensed Matter, Structure, Defects and Mechanical Properties, 1989, 60, 321-337.	0.6	26
308	Growth of InSb and InAs $_{1-x}$ Sb $_x$ on GaAs by molecular beam epitaxy. Applied Physics Letters, 1988, 53, 1092-1094.	3.3	110
309	Electrical properties of InAs epilayers grown by molecular beam epitaxy on Si substrates. Applied Physics Letters, 1988, 53, 562-564.	3.3	26
310	Band lineup in GaAs $_{1-x}$ Sb $_x$ /GaAs strained-layer multiple quantum wells grown by molecular-beam epitaxy. Physical Review B, 1988, 38, 10571-10577.	3.2	54
311	Growth and transport properties of InAs epilayers on GaAs. Applied Physics Letters, 1988, 53, 1647-1649.	3.3	30
312	Extremely low nonalloyed and alloyed contact resistance using an InAs cap layer on InGaAs by molecular beam epitaxy. Journal of Applied Physics, 1988, 64, 429-431.	2.5	20
313	Process study of chemically vapour-deposited SnO $_x$ ($x \approx 2$) films. Thin Solid Films, 1983, 106, 163-173.	1.8	25
314	In $_{0.29}$ Al $_{0.71}$ As/In $_{0.3}$ Ga $_{0.7}$ As heterostructure field-effect transistors fabricated on GaAs substrates. , 0, , .		0
315	0.2 μ m AlGaAs/InGaAs pseudomorphic HEMT fabricated by optical lithography. , 0, , .		0
316	The effects of AlGaAs cap layers on the dc and speed performance of GaAs metal-semiconductor-metal photodetectors. , 0, , .		1
317	In $_{0.52}$ Al $_{0.48}$ As/In $_{0.53}$ Ga $_{0.47}$ As HEMT's on InP substrates. , 0, , .		0
318	In $_{0.52}$ (Al $_{0.9}$ Ga $_{0.1}$) $_{0.48}$ As/In $_{0.53}$ Ga $_{0.47}$ As HEMTs on InP substrates. , 0, , .		0
319	Lattice-matched In $_{0.29}$ Al $_{0.71}$ As/In $_{0.3}$ Ga $_{0.7}$ As doped-channel FETs. , 0, , .		0
320	Analysis of the temperature dependence of 1.3 μ m AlGaInAs/InP multiple quantum-well lasers. , 0, , .		0
321	Optical and material studies of indium compositional fluctuations in InGaN/GaN quantum well structures. , 0, , .		0
322	Microstructure studies of InGaN/GaN multiple quantum wells. , 0, , .		2
323	Two-component photoluminescence decay and carrier localization in InGaN/GaN multiple quantum well structures. , 0, , .		0
324	Low current-blocking InGaAs/InP DHBT grown by solid-source MBE. , 0, , .		0

#	ARTICLE	IF	CITATIONS
325	Selective growth of InAs quantum dots on patterned GaAs substrate by metal-organic chemical vapor deposition. , 0, , .		0
326	Luminescence efficiency of InGaN multiple quantum well UV-LEDs. , 0, , .		0
327	Conductance mapping for the electron and hole energy levels in InAs/GaAs self-assembled quantum dots. , 0, , .		0
328	Conversion efficiency and device behavior of edge-coupled membrane photonic transmitters. , 0, , .		0
329	Effects of thermal annealing on InGaN/GaN quantum well structures with silicon doping. , 0, , .		0
330	Luminescence efficiency of InGaN-based multiple quantum well UV-LEDs. , 0, , .		0
331	InGaAs/InP heterojunction bipolar transistors with low offset voltage and current blocking. , 0, , .		0
332	Optical properties of InAs quantum dots with InAlAs/InGaAs composite matrix. , 0, , .		0
333	Effects of dot height uniformity on the performance of 1.3 μm InAs quantum dot lasers. , 0, , .		0
334	InGaAsN/GaAs quantum well lasers using two-step and nitride passivation growth. , 0, , .		0
335	0.2 μm AlGaAs/InGaAs pseudomorphic HEMT fabricated by optical lithography. , 0, , .		0
336	The effects of AlGaAs cap layers on the dc and speed performance of GaAs metal-semiconductor-metal photodetectors. , 0, , .		0